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Company:	US Patent Office	Date:	September 20, 2007
Fax:	(571) 273-8300	Pages:	8 (including cover sheet)
Your Re:	10/822,361	Our Re:	ITL0835D1US

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Applicant:	Ilya Karpov et al.	§	Art Unit:	2814
Serial No.:	10/822,361	§	Examiner:	Long Pham
Filed:	April 12, 2004	§	Docket:	ITL.0835D1US P14730D
For:	Fabricating Deeper and Shallower Trenches in Semiconductor Structures	§	Assignee:	Intel Corporation
		§	Conf. No.	3077

Mail Stop AF
Commissioner for Patents
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REPLY TO FINAL REJECTION

Sir:

In response to the final rejection mailed August 15, 2007, please amend the above-referenced patent application as follows:

Date of Deposit: September 20, 2007
I hereby certify that this document is being facsimile transmitted to the
United States Patent and Trademark Office (Fax No. 571/273-8300) on the
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Cynthia L. Hayden
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